

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In re PATENT APPLICATION of

Applicant(s) : Hiroyuki YOSHIMURA)

Appln. No. : To Be Assigned)

Filed : March 1, 2004)

For : MASTER DISK FOR MAGNETIC PRINTING)
AND MANUFACTURING METHOD THEREOF)

Atty. Dkt. : FEC-109)

**INFORMATION
DISCLOSURE
STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of one Japanese patent publication and PCT/JP99/05804 with English-language abstracts. The two Japanese publications are discussed on page 2 of the application. Any documents are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted document is respectfully requested.

Respectfully submitted,



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March 1, 2004
Date

SMR/tl

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty Docket FEC 109		Application No. To Be Assigned			
				Applicant Hiroyuki YOSHIMURA					
				Filing Date March 1, 2004				Group Unit To Be Assigned	
U.S. PATENT DOCUMENTS									
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date		
	AA								
	AB								
	AC								
	AD								
	AE								
	AF								
	AG								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country	Class	Sub- Class	Trans- lation		
	AH	2001-034938	2/09/01	Japan			Abstract		
	AI	WO00/26904	05/11/00	WIPO			Abstract		
	AJ								
	AK								
	AL								
	AM								
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OTHER (Including Author, Title, Date, Pertinent Pages, etc.)									
	AP								
Examiner					Date Considered				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.									